

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No. 253/006

In re patent application of

Group Art Unit: 1775

Jung-Ho LEE, et al.

Serial No. 09 686,624

Examiner: S. Stein

Filed: October 12, 2000

For: SPIN-ON GLASS COMPOSITION AND METHOD OF FORMING SILICON OXIDE LAYER IN SEMICONDUCTOR MANUFACTURING PROCESS USING THE SAME

## RESPONSE TO RESTRICTION REQUIREMENT

Hon. Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

In response to the Office Action dated April 30, 2002, applicants hereby elect the claims of Group II, claims 10-28, for prosecution in the subject application.

Applicants, of course, reserve the right to file a divisional application covering the subject matter of the non-elected claims.

Receipt of the initial Office Action on the merits is awaited.

Respectfully submitted, LEE & STERBA, P.C.

May 30, 2002 Date

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